Application No.: 09/891,534 Docket No.: 8733.469.00-US

## **LISTING OF THE CLAIMS**

- 1-53. (Cancelled)
- 54. (Previously Presented): A liquid crystal display (LCD) device comprising:
  - a first substrate and a second substrate;
- an inorganic insulating layer made of one of silicon oxide and silicon nitride on a first side of the first substrate;
- a light emitting structure including an organic light emitting layer on the inorganic insulating layer;
  - a protective layer on the light emitting structure to protect the light emitting structure;
- a thin film transistor (TFT) array structure including thin film transistors and pixel electrodes on a second side of the first substrate, wherein the first side is opposite to the second side;
  - a common electrode on a surface of the second substrate; and
- a liquid crystal layer between the first substrate and the second substrate, whereby the light emitting structure shares the first substrate with the TFT array structure.
- 55. (Previously Presented): The LCD of claim 54, wherein the light emitting structure is a light emitting diode.
- 56. (Previously Presented): The LCD of claim 54, wherein the light emitting structure comprises:
  - a first electrode disposed on the inorganic insulating layer; the organic light emitting layer on the first electrode; and a second electrode on the organic light emitting layer.

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57. (Previously Presented): The LCD of claim 56, wherein the organic light emitting layer comprises:

a hole transport layer; an organic light emitting layer; and an electron transport layer.

- 58. (Previously Presented): The LCD of claim 54, wherein the organic light emitting layer comprises any one of Alq3 (tris-8-hydroxyquinolinato aluminum), BeBq (bis-benzo-quinolinato-berellium), PPV (polyphenylenevinylene) or polyalkylthiphene.
- 59. (Previously Presented): The LCD of claim 56, wherein the first electrode is indium tin oxide.
- 60. (Previously Presented): The LCD of claim 54, wherein the first substrate is composed of an organic material.
- 61. (Previously Presented): The LCD of claim 60, wherein the first substrate performs an additional function of polarization.
- 62. (Previously Presented): The LCD of claim 54, wherein the protective layer includes SiOx or IOx.
- 63. (Withdrawn): A method for fabricating a liquid crystal display (LCD) device, comprising: depositing a first insulating layer on a first surface of a first substrate;

after depositing the first insulating layer, sequentially depositing a first electrode on the first insulating layer, an organic film layer on the first electrode and a second electrode on the organic film layer to form a light emitting structure;

after forming the light emitting structure, depositing a protective layer to protect the light emitting structure;

forming a thin film transistor array on a second surface of the first substrate; providing a liquid crystal layer on the second surface of the first substrate; and attaching the first substrate to a second substrate.

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64. (Withdrawn): The method of claim 63, wherein the light emitting structure is a light emitting diode.

- 65. (Withdrawn): The method of claim 63, wherein forming the organic film layer comprises: forming a hole transport layer; forming an organic light emitting layer; and forming an electron transport layer.
- 66. (Withdrawn): The method of claim 65, wherein the organic light emitting layer comprises any one of Alq3 (tris-8-hydroxyquinolinato aluminum), BeBq (bis-benzo-quinolinato-berellium), PPV (polyphenylenevinylene) or polyalkylthiphene.
- 67. (Withdrawn): The method of claim 63, wherein the first electrode is indium tin oxide.
- 68. (Withdrawn): The method of claim 63, wherein the first substrate is comprised of an organic material.
- 69. (Withdrawn): The method of claim 68, wherein the first substrate performs an additional function of polarization.
- 70. (Withdrawn): The method of claim 63, wherein the first insulating layer includes either SiOx or SiNx.
- 71. (Withdrawn): The method of claim 63, wherein the protective layer includes SiOx or IOx.

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